

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Nobuo NAITO et al.

Application No.: 10/569,512

Filed: February 27, 2006

Docket No.: 127198

For: ELECTROMAGNETIC WAVE SHIELDING FILM FOR PLASMA DISPLAY

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of one or more non-English language reference is discussed in the present specification. See References 9-14.
- ☒ 3. One or more reference cited herein was cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information. See References 1-8.
- ☒ 4. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- ☒ 5. An English language Abstract of one or more non-English language reference is attached hereto. See References 3-14.
- ☒ 6. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office (<http://www.jpo.go.jp>), and is attached, but has not been reviewed for accuracy. See References 3-14.

Respectfully submitted,


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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
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Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 127198		APPLICATION NO. 10/569,512	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Nobuo NAITO et al.			
				FILING DATE February 27, 2006			
U.S. PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Name			
	1	US 2003/0094296 A1	05/22/2003	Kojima et al.			
	2	US 2003/0007341 A1	01/09/2003	Shimamura et al.			
FOREIGN PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation	
	3	JP A 2003-086991	03/20/2003	JAPAN	X	X	
	4	JP A 2003-005663	01/08/2003	JAPAN	X	X	
	5	JP A 2000-265087	09/26/2000	JAPAN	X	X	
	6	JP A 2001-053488	02/23/2001	JAPAN	X	X	
	8	JP A 2003-023290	01/24/2003	JAPAN	X	X	
	9	JP A 2003-015533	01/17/2003	JAPAN	X	X	
	10	JP A 2003-066854	03/05/2003	JAPAN	X	X	
	11	JP A 2000-324431	11/08/2002	JAPAN	X	X	
	12	JP A 2000-235115	08/29/2000	JAPAN	X	X	
	13	JP A 2000-137442	05/16/2000	JAPAN	X	X	
	14	JP A 10-186127	07/14/1998	JAPAN	X	X	
OTHER DOCUMENTS							
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)					
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: April 3, 2006